



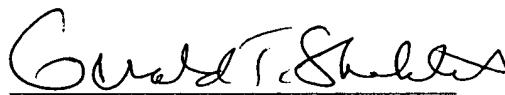
PATENT
Attorney Docket No. 1110/90738

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application) Confirmation No.: 1669
)
 Applicant: Komiya et al.)
)
 Serial No.: 10/679,031)
)
 Filed: October 3, 2003)
)
 For: **SILICON WAFER AND**)
METHOD FOR MANUFACTURE THEREOF,)
AND METHOD OF EVALUATION OF SILICON)
WAFER)
)
 Examiner: M.J. Song)
)
 Art Unit: 1722

I hereby certify that this correspondence is being deposited with the United Postal Service as first class mail in an envelope addressed to: Mail Stop AMENDMENT, Commissioner of Patents, P.O. Box 1450, Alexandria, VA, 22313-1450.

January 11, 2007



Gerald T. Shekleton Reg. No. 27,466

AMENDMENT

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

The Office Action of July 14, 2006, has been carefully reviewed and the following amendments and remarks are made in response thereto.